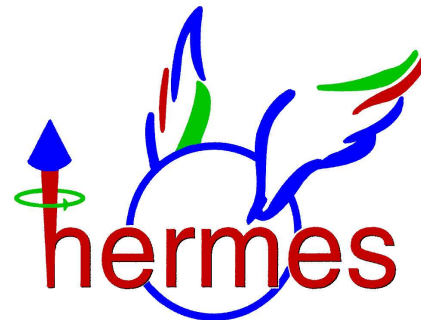


A Silicon Recoil Detector for the HERMES Experiment

A. Vandenbroucke

University Gent



On behalf of the HERMES collaboration

Outline

1. The HERMES Experiment
2. Recoil Detector
3. Silicon Recoil Detector
 - ➡ Sensors, Frame, Hybrid, Foils, Tests
4. Summary

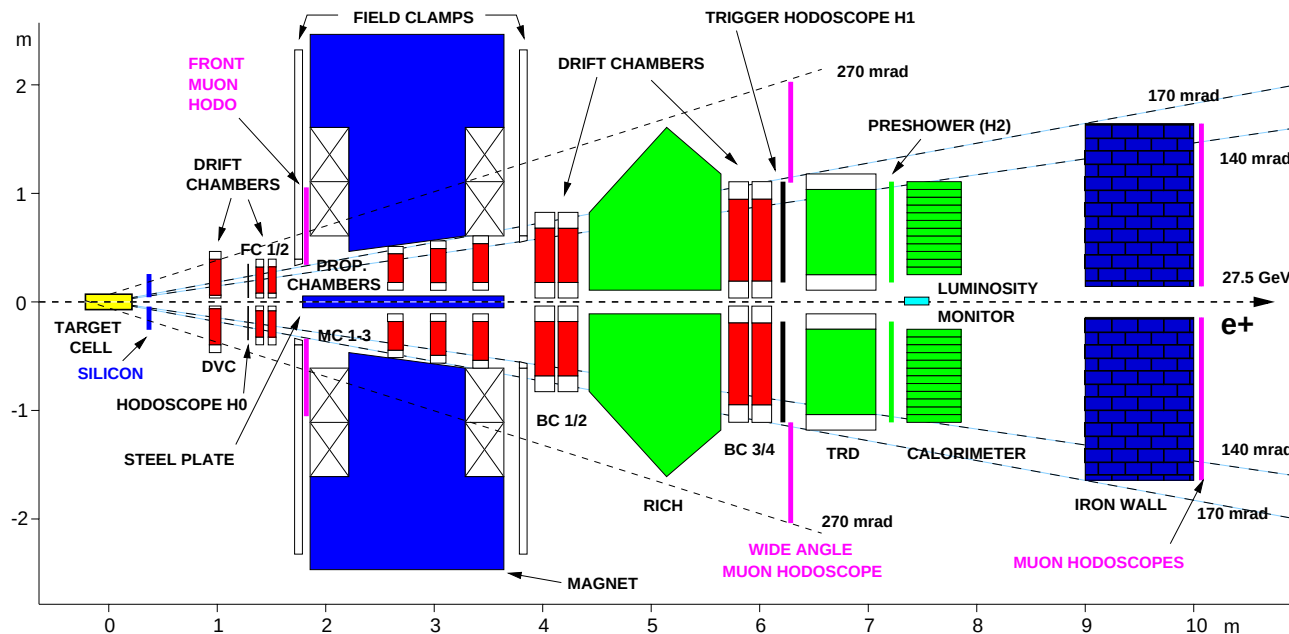
The HERMES Experiment



HERA
MEasurement
of Spin

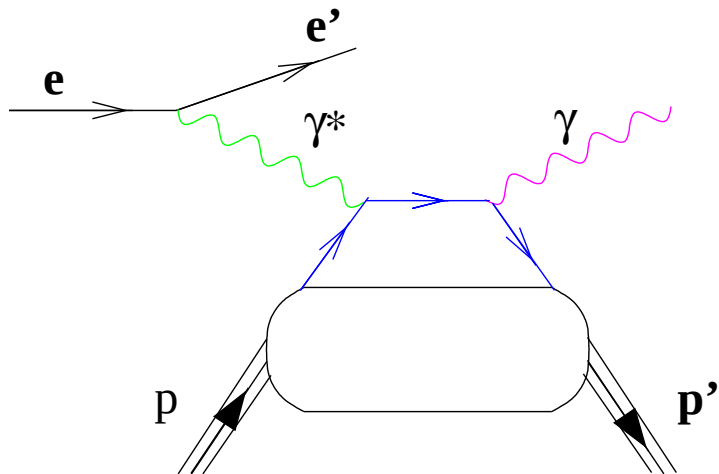
- Experiment at DESY Hamburg
- 27,5 GeV longitudinally polarised $e^{\pm}$ from HERA accelerator
- $\langle Q^2 \rangle = 2.5 \text{ GeV}^2$

The HERMES Experiment



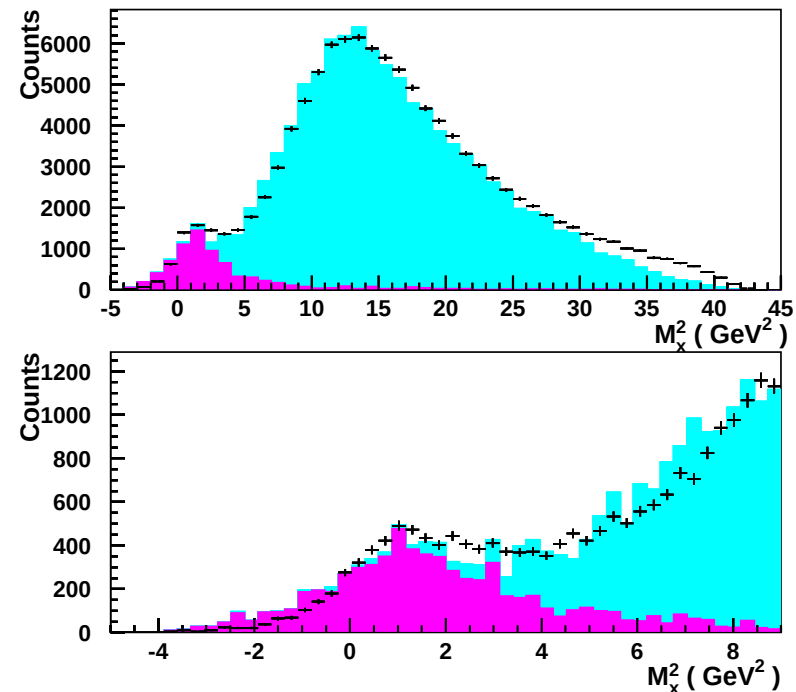
- Internal polarized gas target (H,D ,He,Ne,Kr)
- Tracking: Silicon, Drift Chambers
- PID: RICH, TRD, E/p Calorimeter

The HERMES Experiment



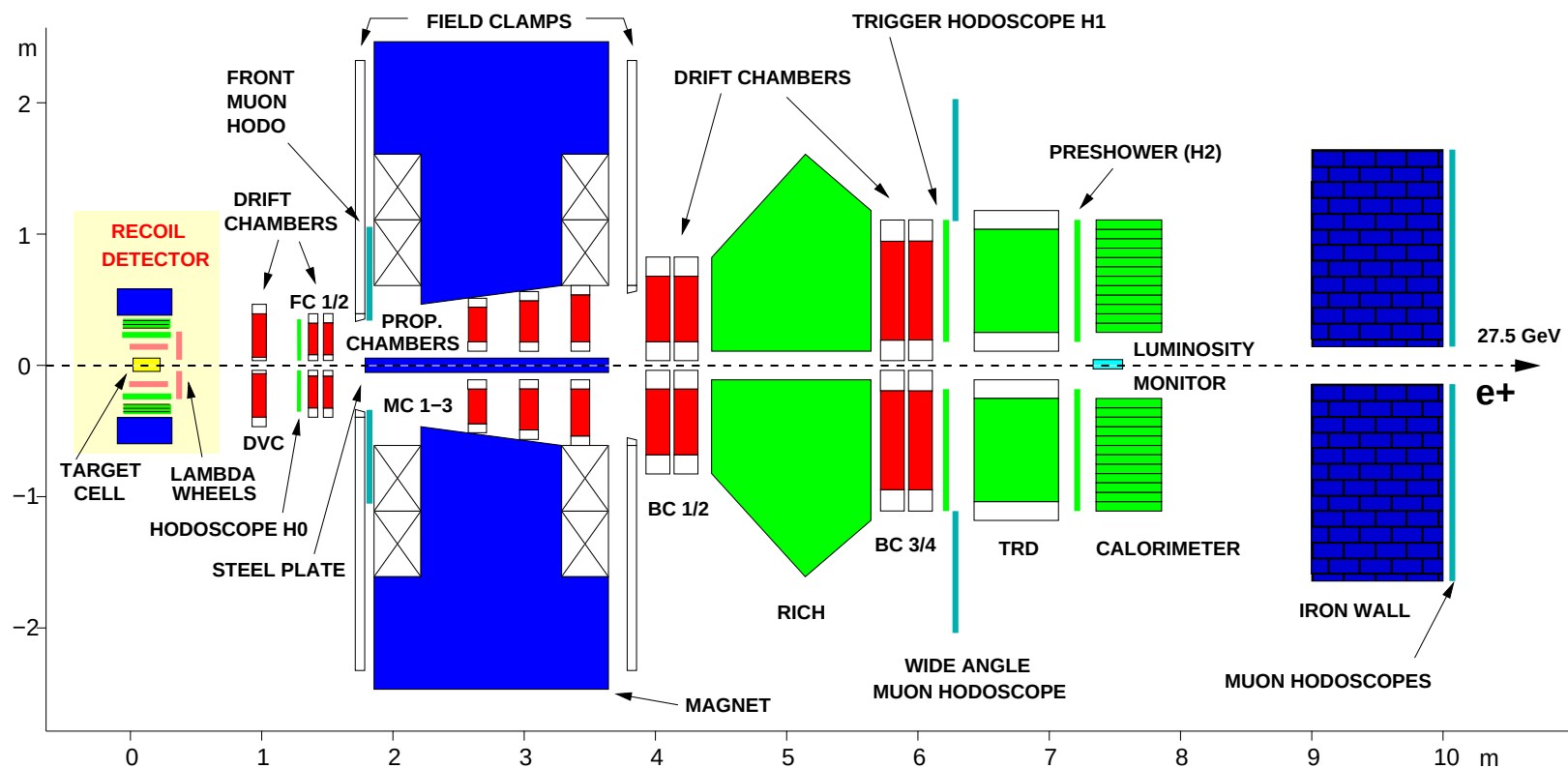
Deeply Virtual
Compton Scattering

Exclusive Processes:
initial and final state fully
known !

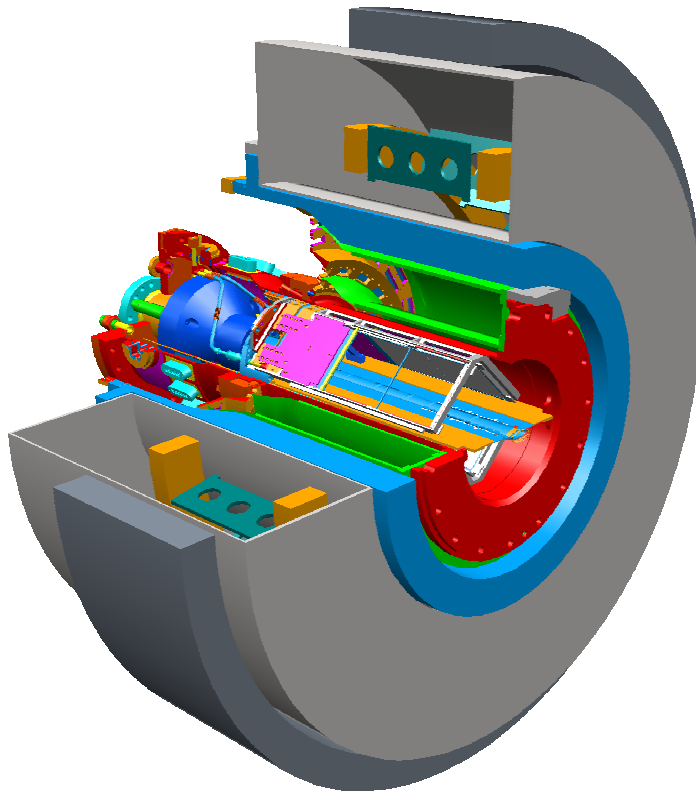


A Recoil Detector for HERMES

To improve the measurement of exclusive processes a Recoil Detector is presently being built.

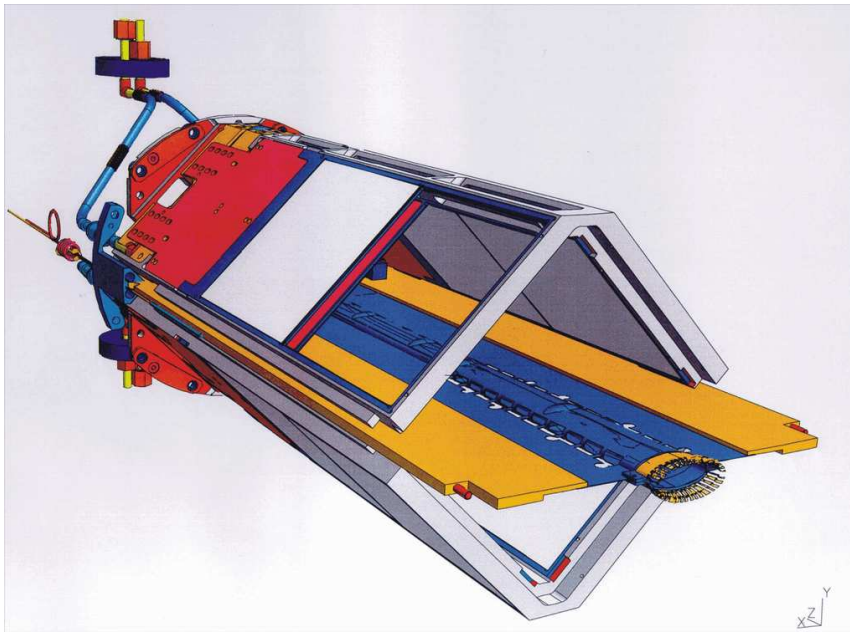


A Recoil Detector for HERMES



- Silicon measuring low momenta protons
- SciFi for momentum and tracking
- Photon detector to improve exclusivity
- Superconducting Magnet providing field for SciFi
- A new collimator to reduce background hits

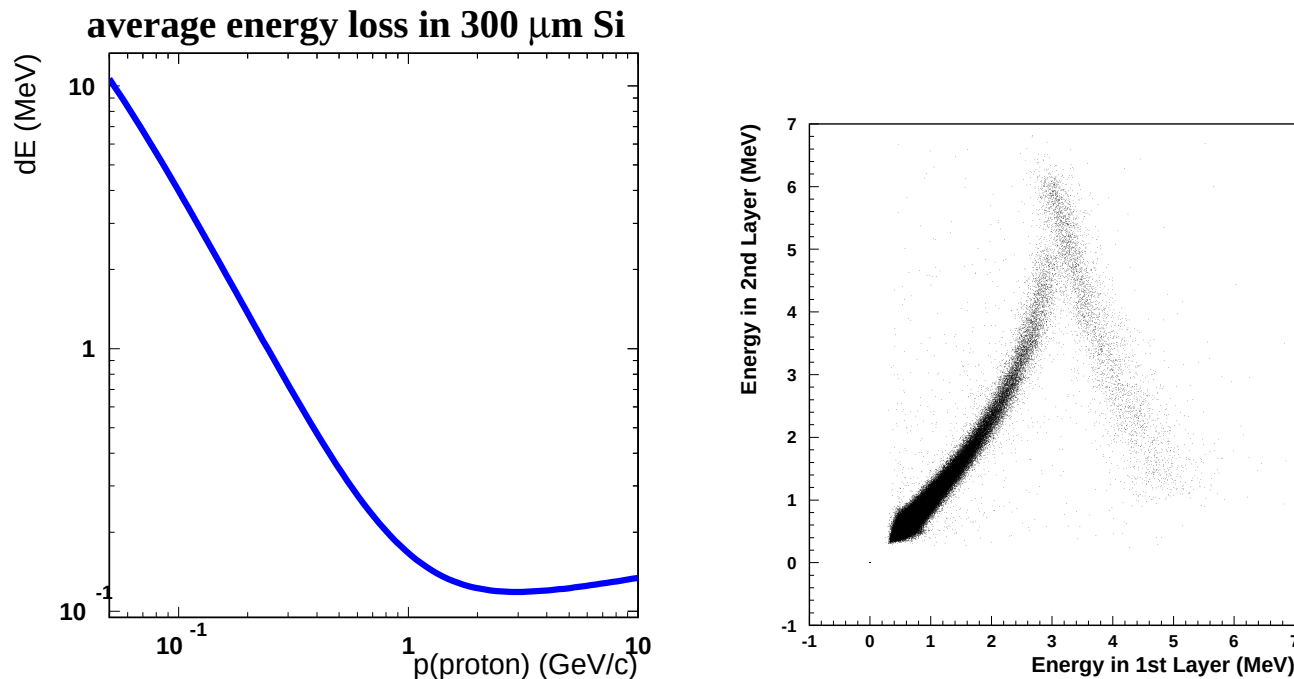
Recoil Silicon Detector



- Inside beam vacuum
- Diamond shape around target cell
- 2 layers of silicon
- 76 % of ϕ
- $23^\circ < \theta < 80^\circ$

► Project of DESY, Erlangen, Gent, Glasgow

Recoil Silicon Detector

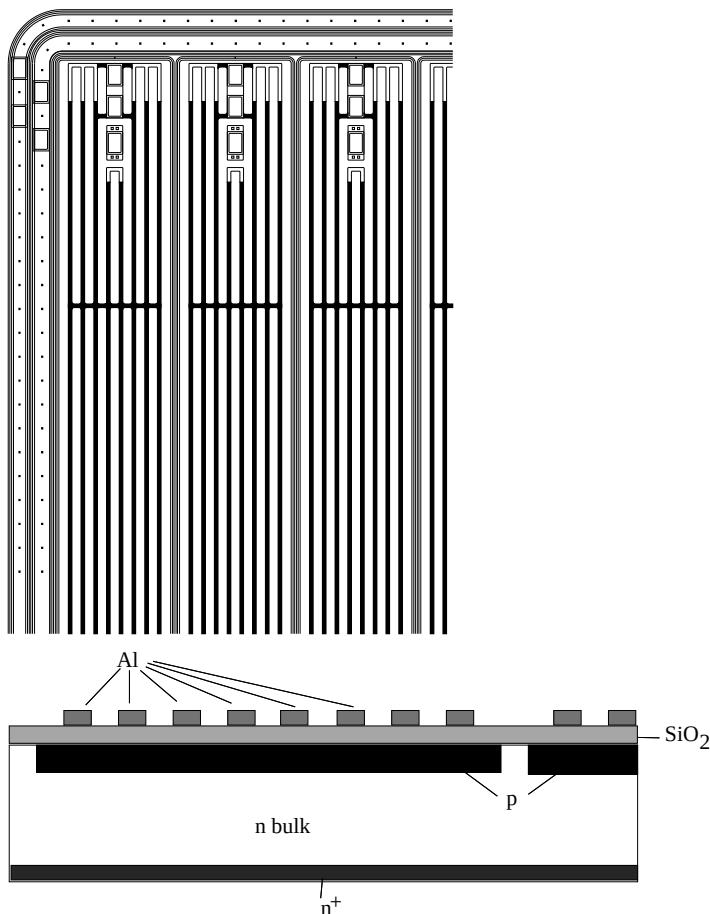


- Large Dynamic Range required
- Vacuum compatible components



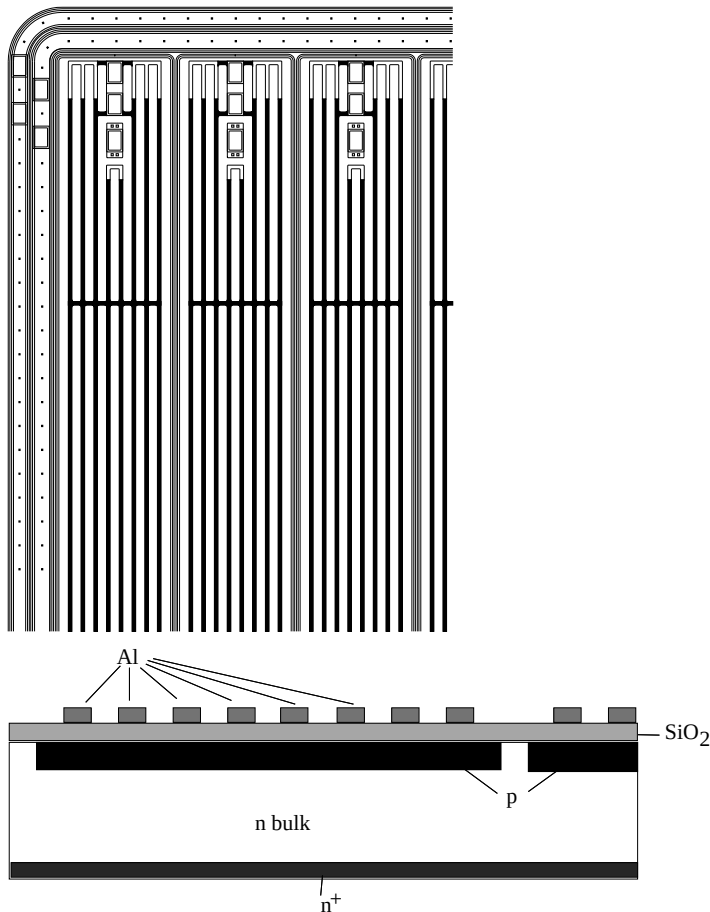
Silicon Sensors

TIGRE sensors



- Largest commercially available silicon sensor
- Double sided
- $99 \times 99 \text{ mm}^2$, $300 \mu\text{m}$ thick
- $758 \mu\text{m}$ pitch
- Strip width: $702 \mu\text{m}$
- SiO₂ layer ensures AC-coupling

TIGRE sensors



- Depletion voltage: 50 V
- Total capacitance p (n) : 52 pF (70 pF)
- Changes to original design:
 - ☐ Thicker SiO₂ layer
 - ☐ Bias Resistor
50 MΩ → 6.5 MΩ

TIGRE sensors

All TIGREs have been tested:

- Bias resistors p/n side for 3 strips
 - 3 strips: left, middle, right
- Interstrip resistance for 3 strips
- Coupling capacitor resistance for 3 strips
- Overall I/V–C/V characteristics: diode functionality, depletion voltage
- Long Term Test



The Holding Frame

A Holding Frame

Requirements for the holding frame:

- Sufficient **stability**
- Suitable for **vacuum** applications
- **Thermal expansion** coefficient close to that of silicon

A Holding Frame

	Silicon	Aluminium	Graphite	Shapal-M	Unit
Resistance	$10^{-4} - 10^4$	$5 \cdot 10^{-6}$	0.02	10^{12}	$\Omega \cdot cm$
Thermal Expansivity	2.6	23	7.4	4.4	$\frac{10^{-6}}{K}$
Modulus of Elasticity	170	70	15	160	GPa
Thermal Conductivity	150	130	65	100	$\frac{W}{m \cdot K}$
Outgassing Rate	n.a.	10^{-10}	$8 \cdot 10^{-11}$	$2.3 \cdot 10^{-11}$	$\frac{mbar \cdot l}{s \cdot cm^2}$
Costs per frame	n.a.	30	110	1200	€

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Go for Shapal-M

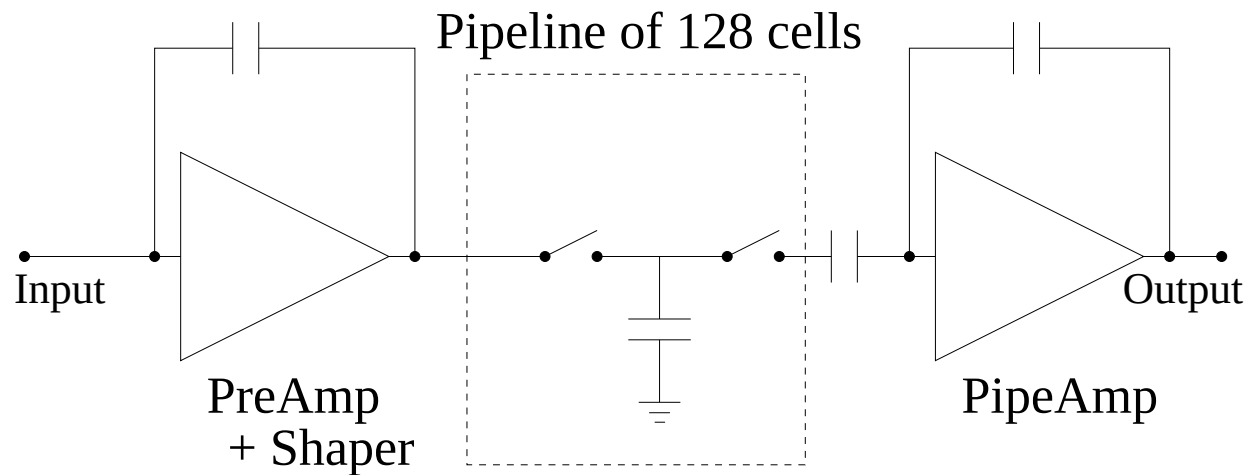
➡ Sensors are glued with two component epoxy glue at 150°



Readout Hybrid

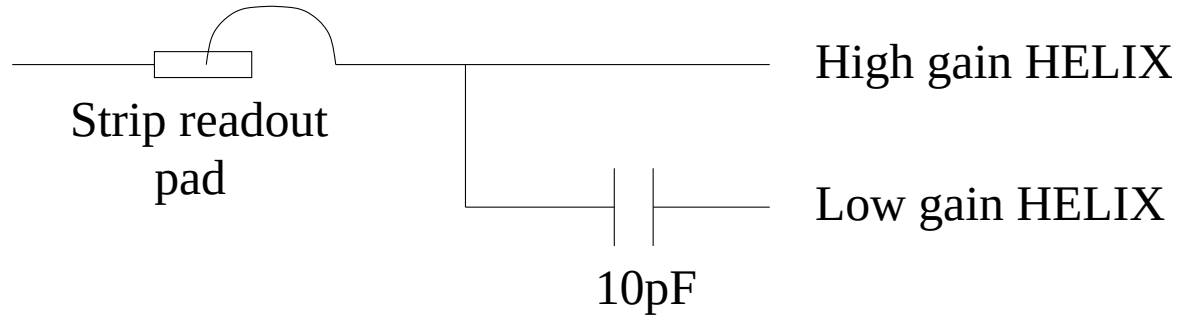
Readout Hybrid

Two readout chip candidates were tested: **APC** and **HELIX128-3.0**



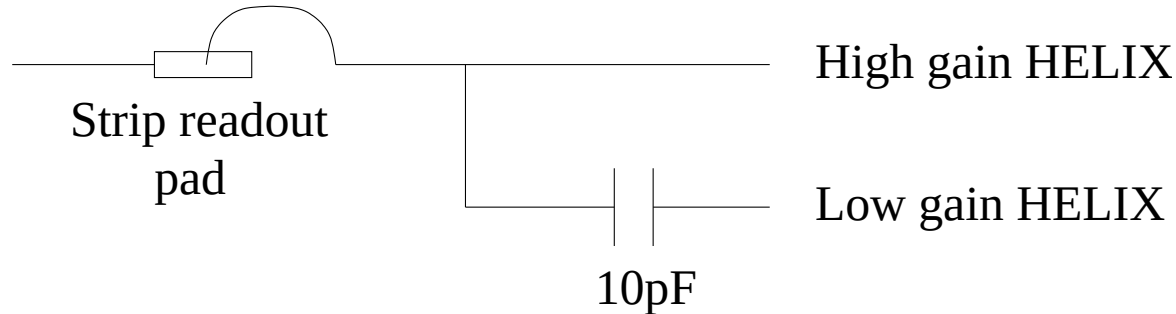
Readout Hybrid

Extend Dynamic range with Charge division method:



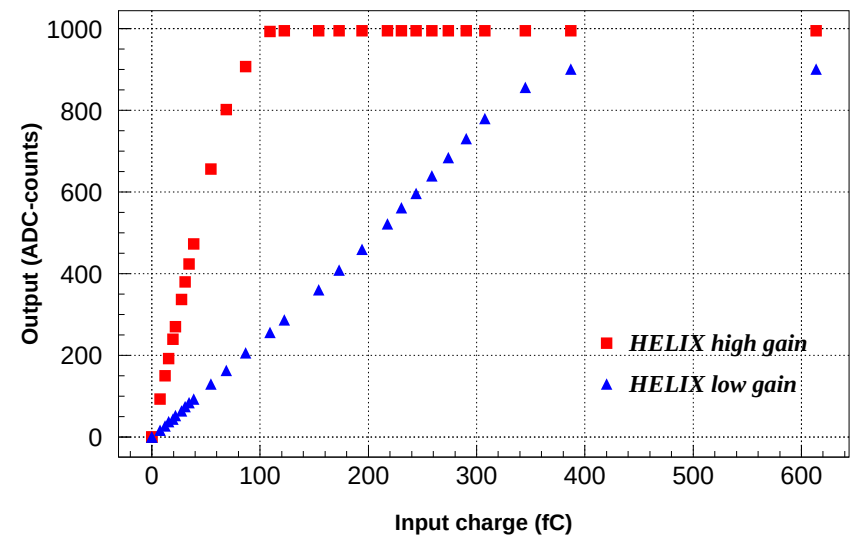
Readout Hybrid

Extend Dynamic range with Charge division method:

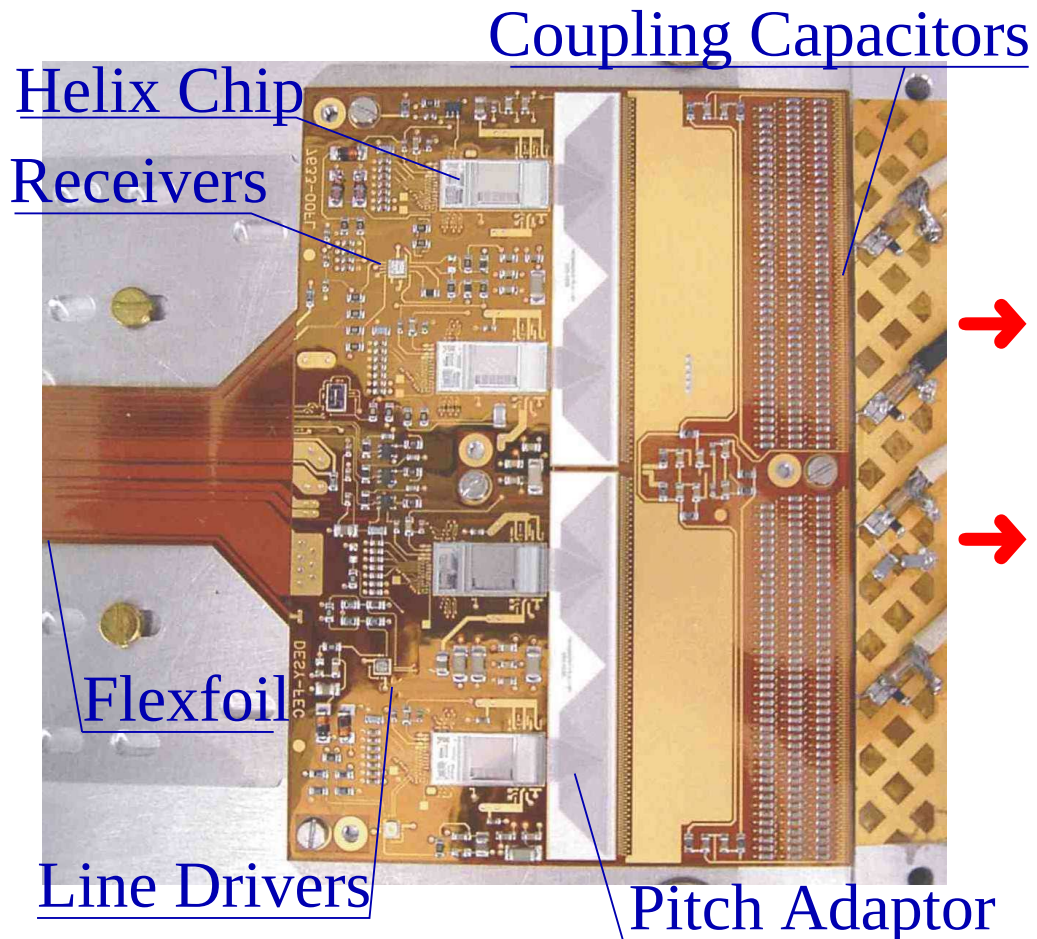


➔ Sufficient Dynamic Range

➔ HELIX already used in HERMES

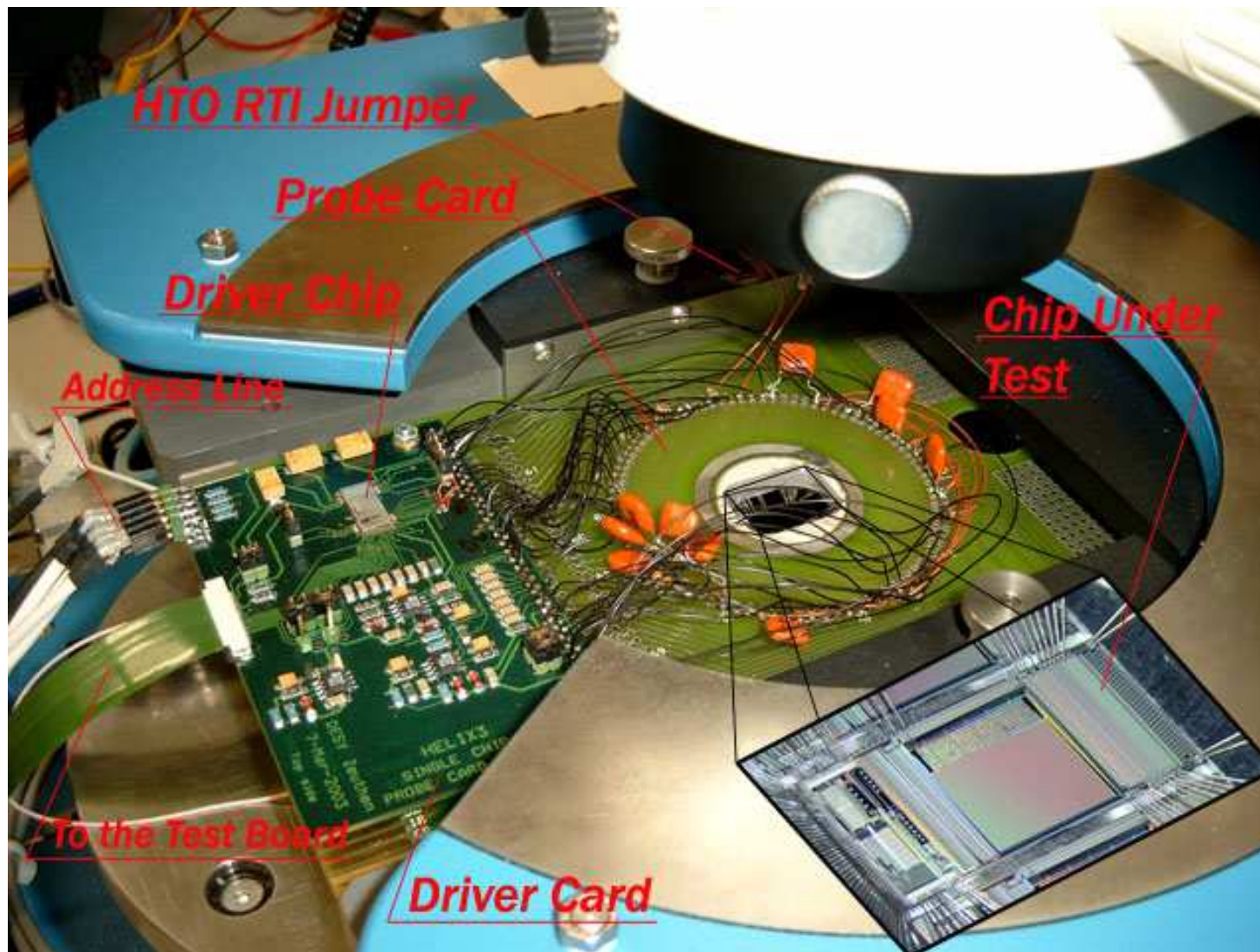


Readout Hybrid



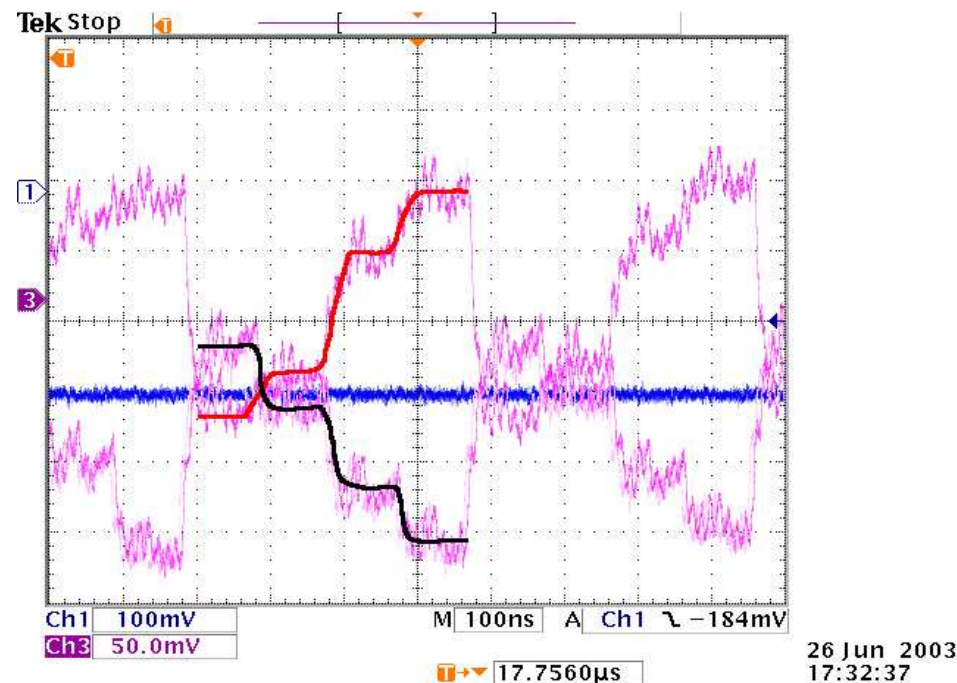
- 4 layers, with kapton cores
- Glued to aluminum heatsink

Chip Tests



Chip Tests

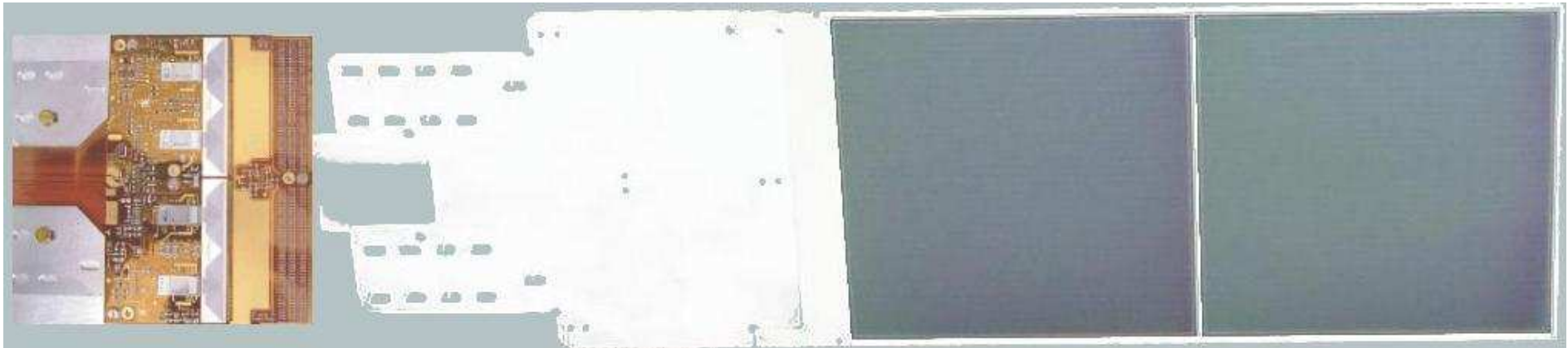
- Basic functionality (addressing, programming)
- Uniformity checked with internal testpulse



Chip Tests

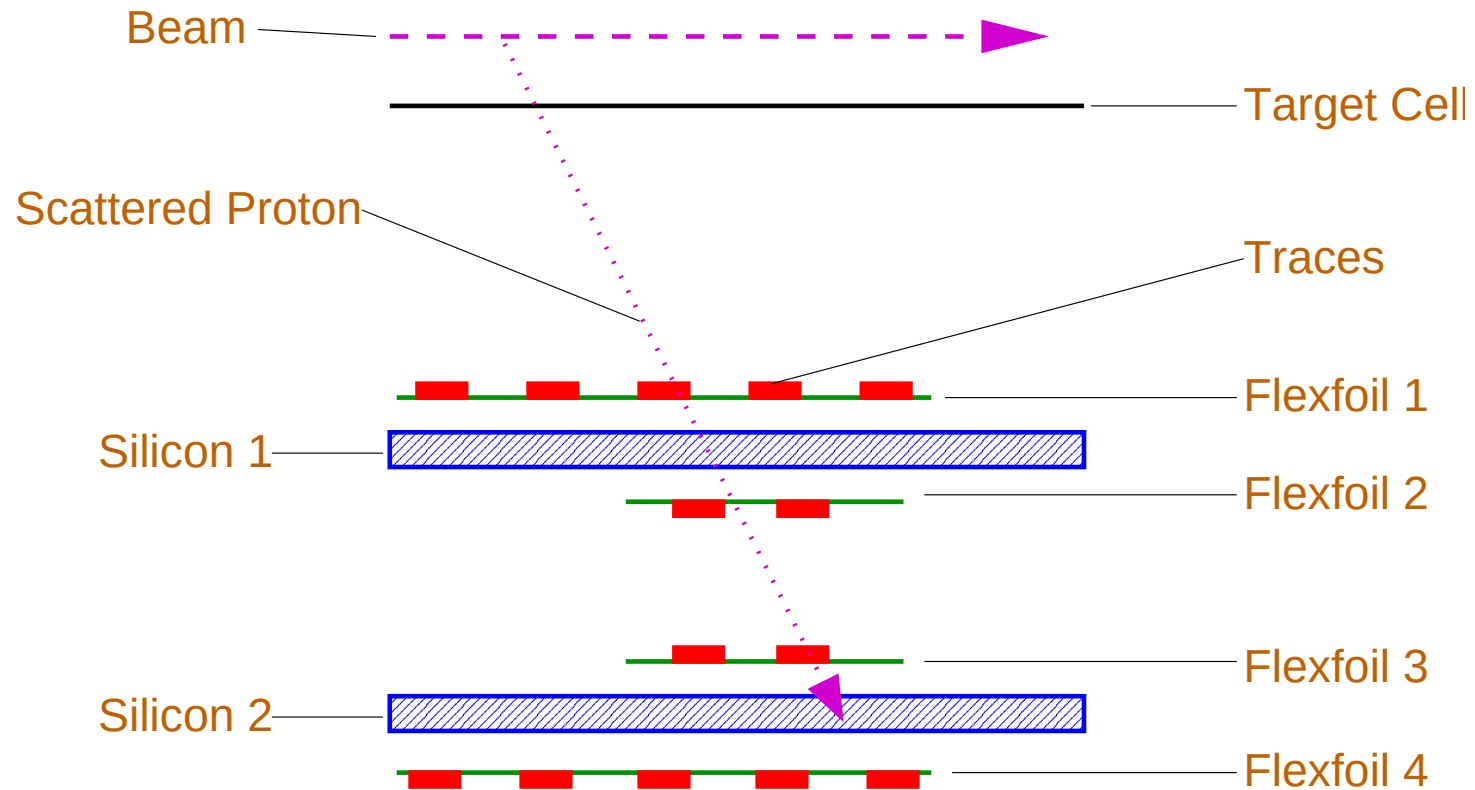
- 372 chips tested
 - 64 chips needed
 - 153 Class A chips
 - 100 Class A1

Kapton Readout foils



⇒ Readout Foils needed !

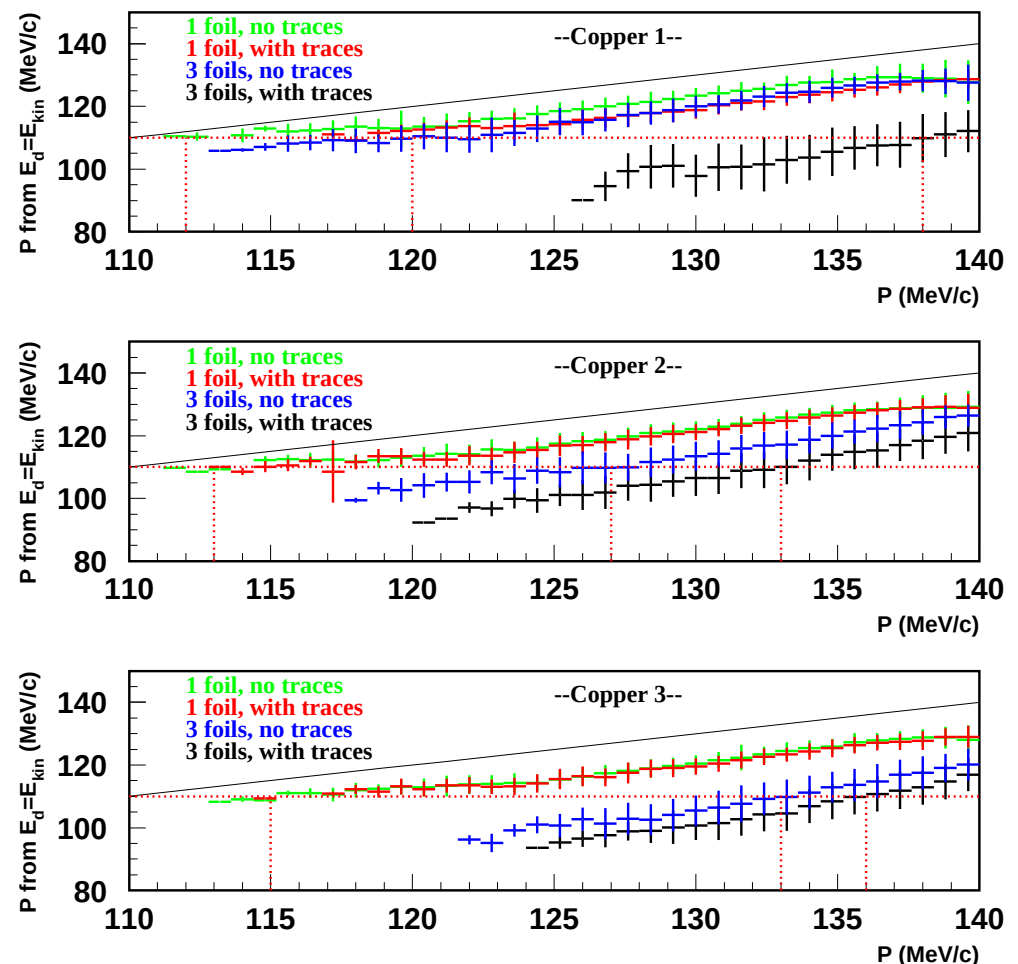
Kapton Readout foils



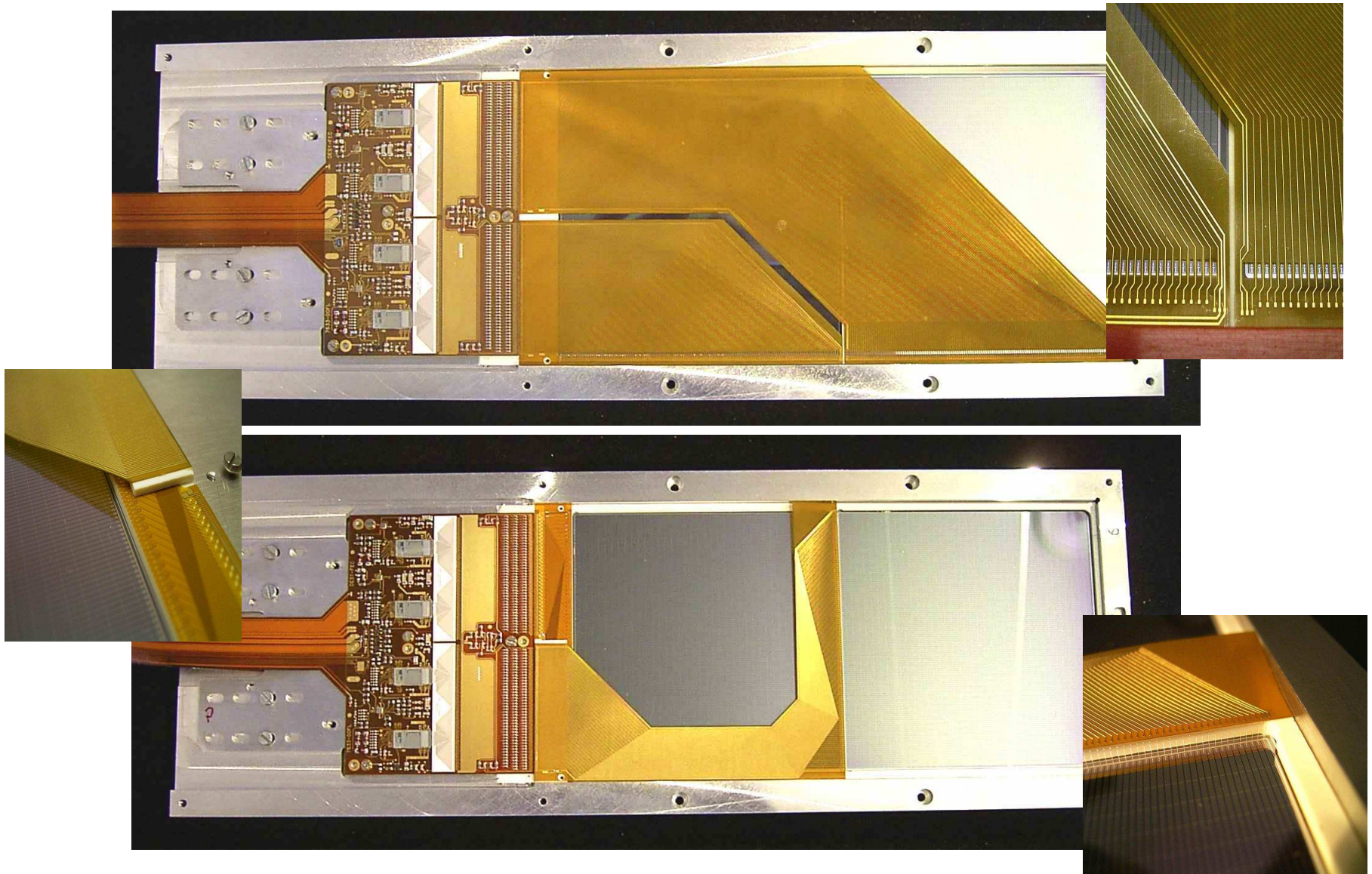
Kapton Readout foils

→ Different designs: (μm)

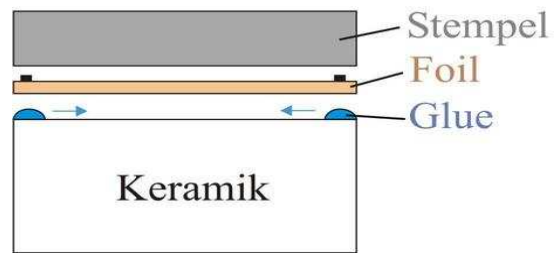
	C1	C2	C3
Kapton	25	50	50
Copper	17	5	5
Nickel	5	5	—
Gold	0.1	0.1	—
Kapton2	—	—	25



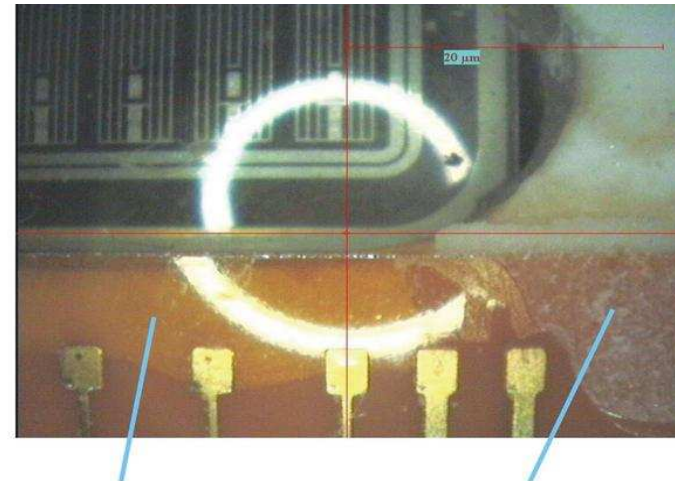
An SRD Module



Assembly-Glueing

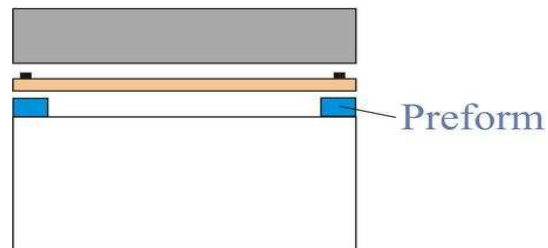


Glue : 2-Component Epoxy
Epotek H77 (Polytec)

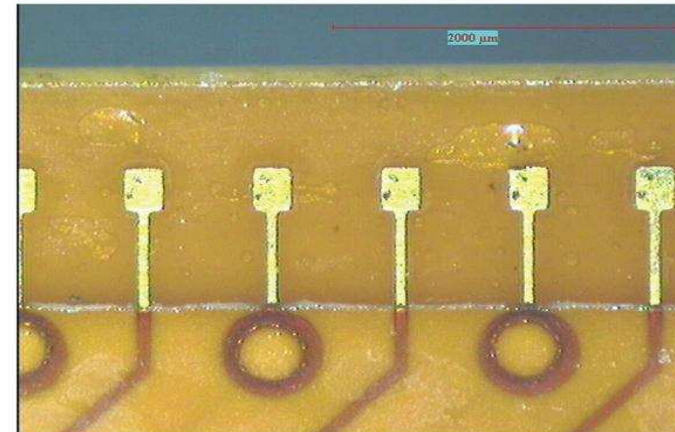


Air bubbles below bondpads

Glue on foil



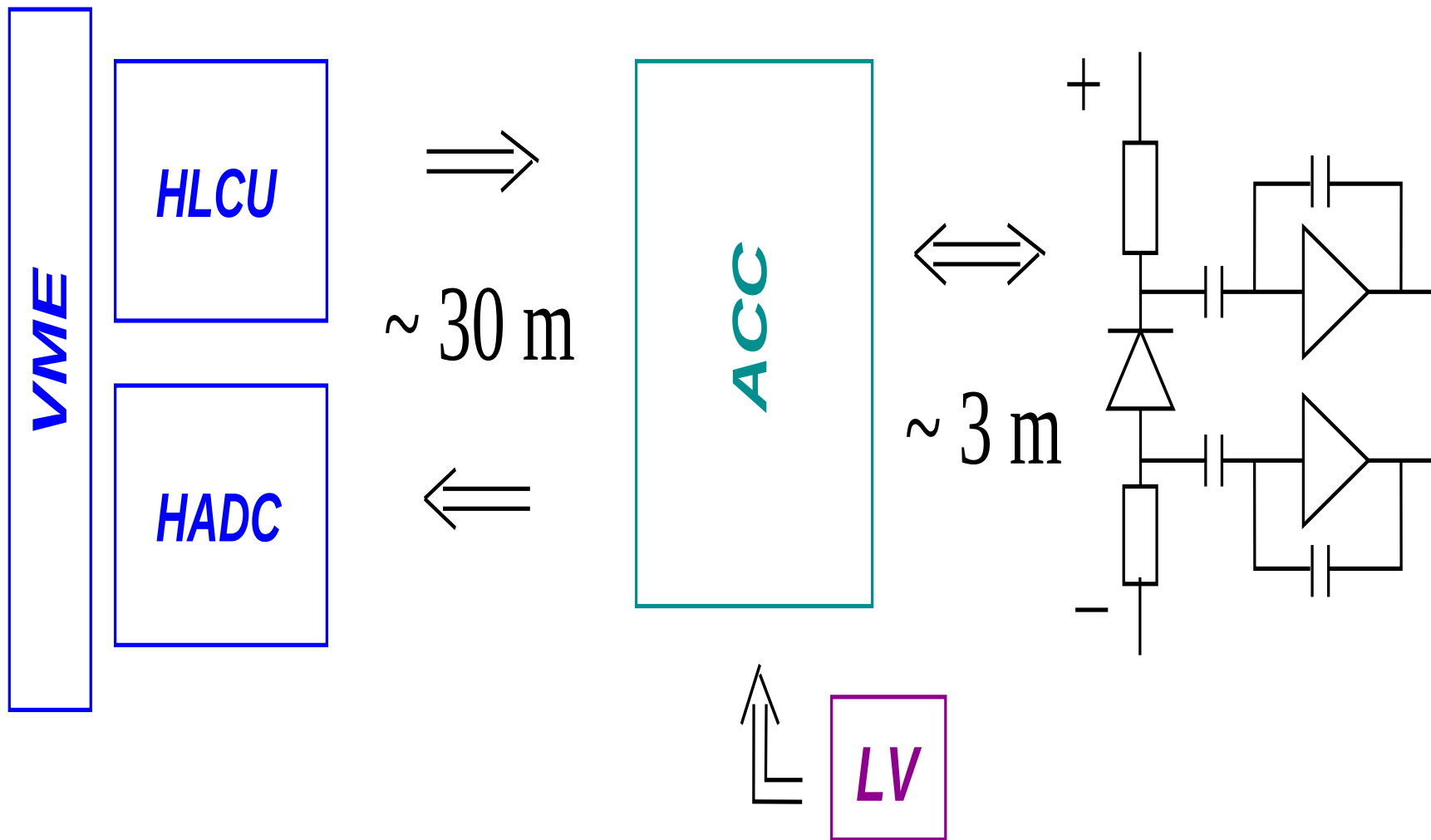
Preform : Woven material filled
with Epoxy Glue.
Polytec TFT D18-1 SP4





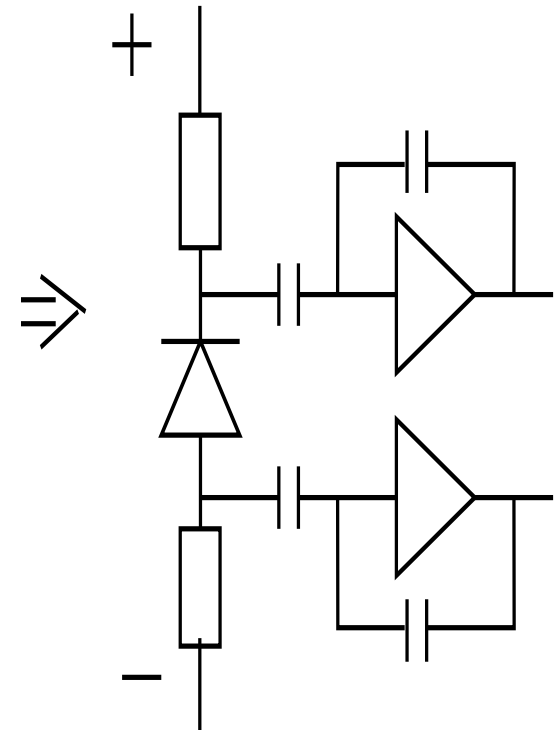
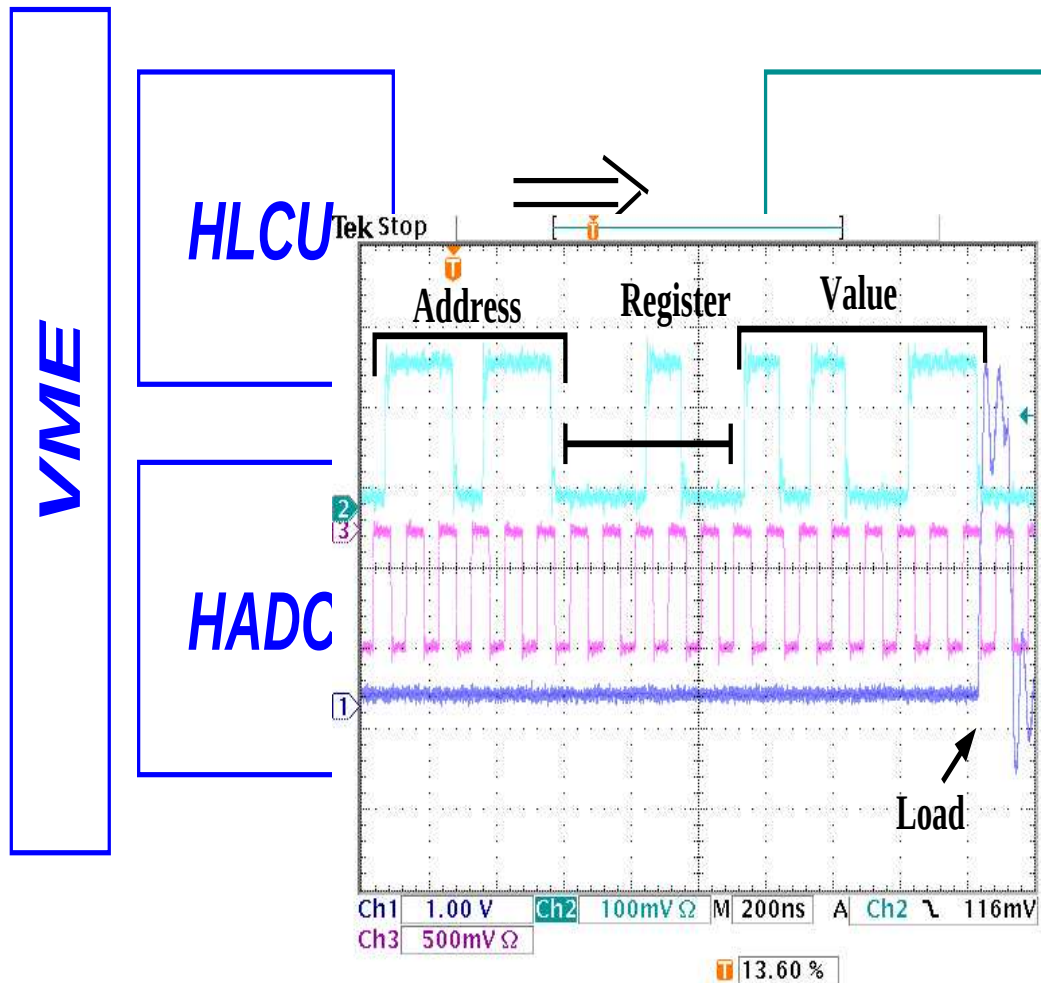
Readout Scheme

Readout Scheme



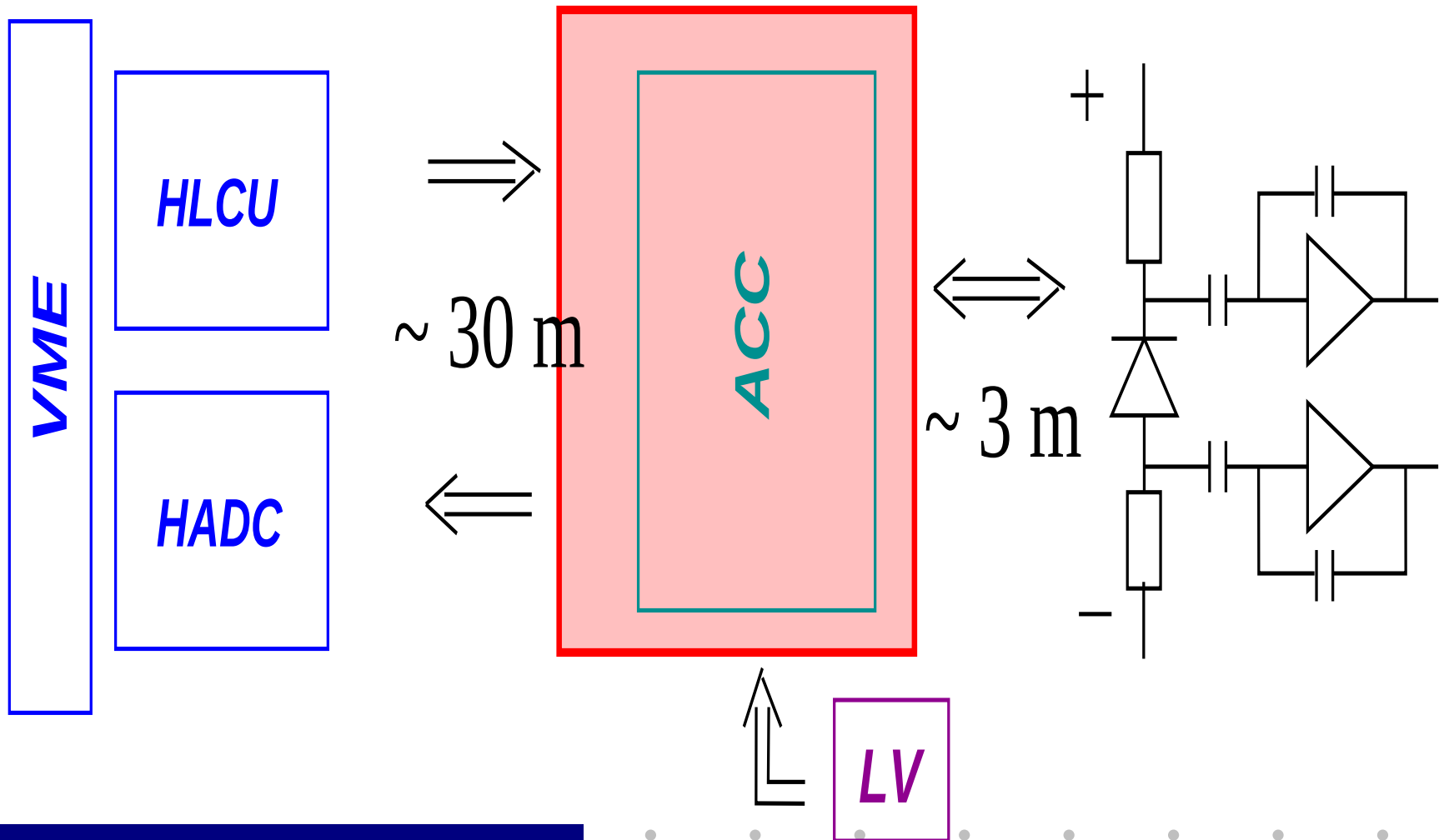
Readout Scheme

HLCU: Programming, Clock, Triggering



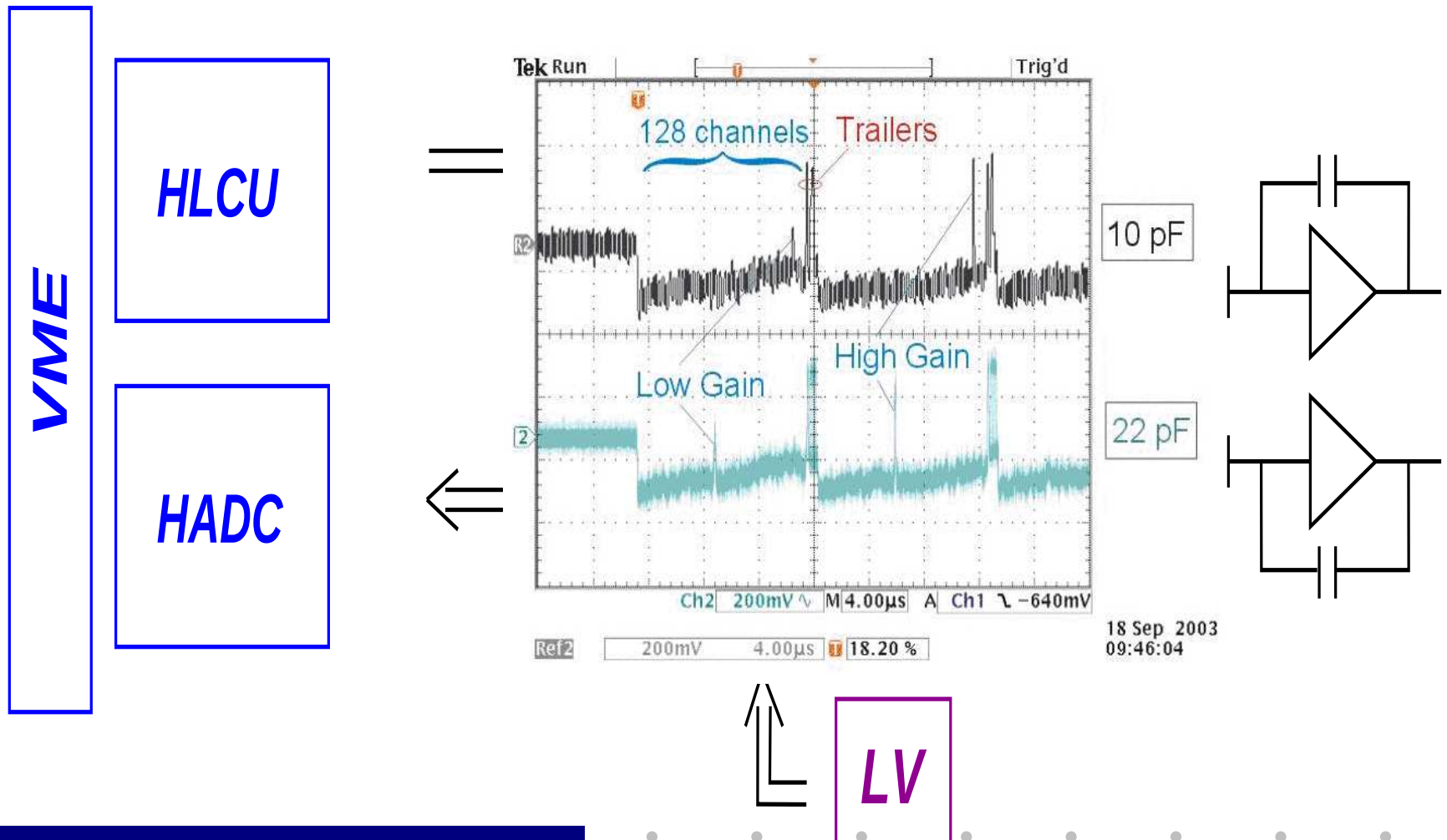
Readout Scheme

ACC: Repeater board, drivers/receivers



Readout Scheme

HADC: ADC, CMC, Zero Suppression





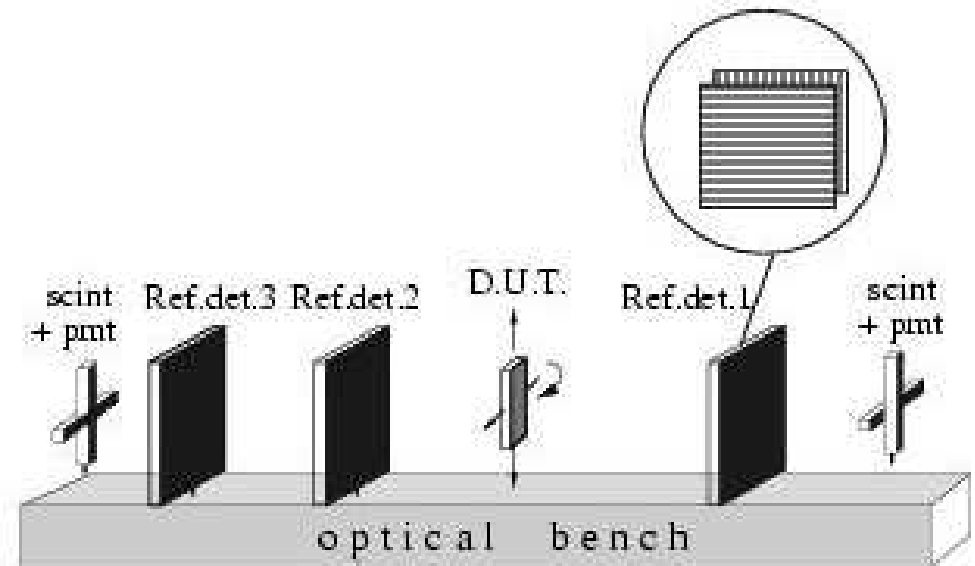
Prototype Testing

Prototype testing

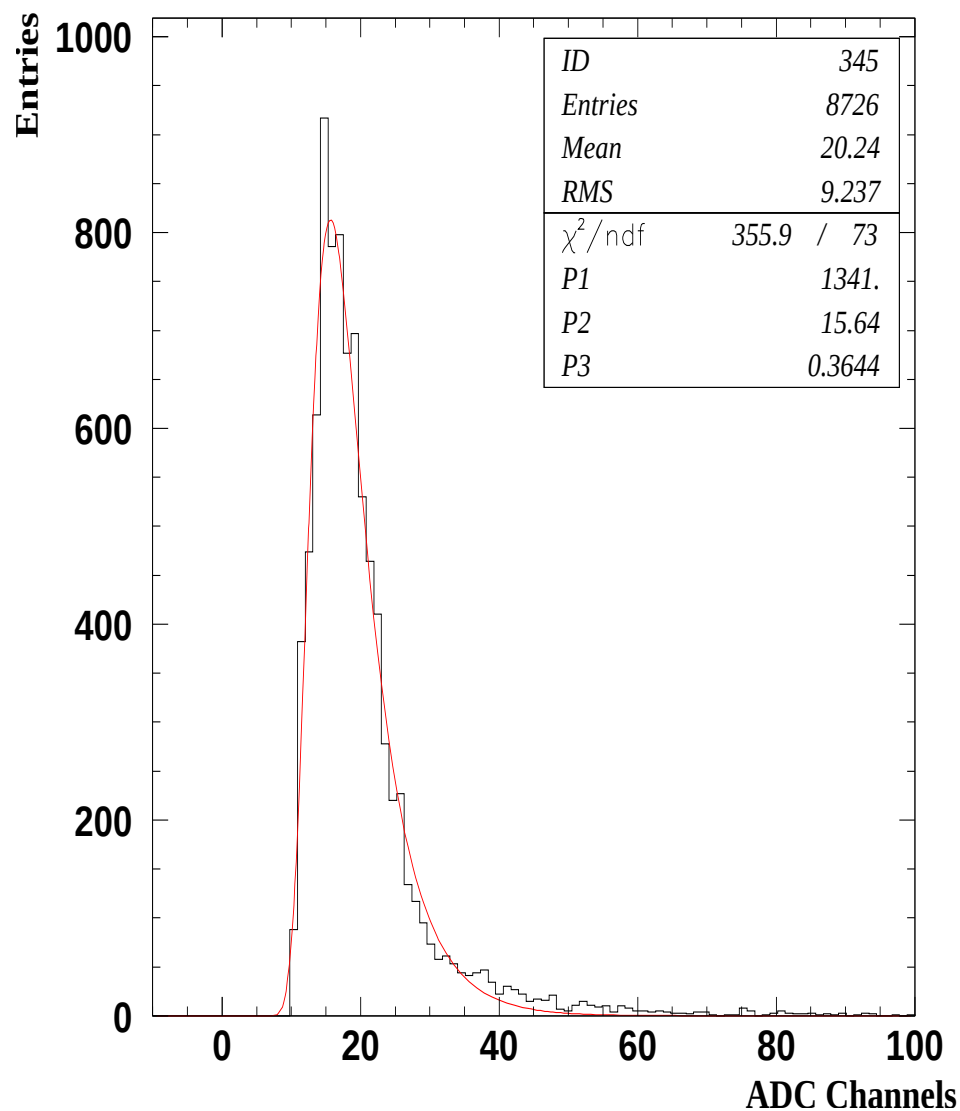
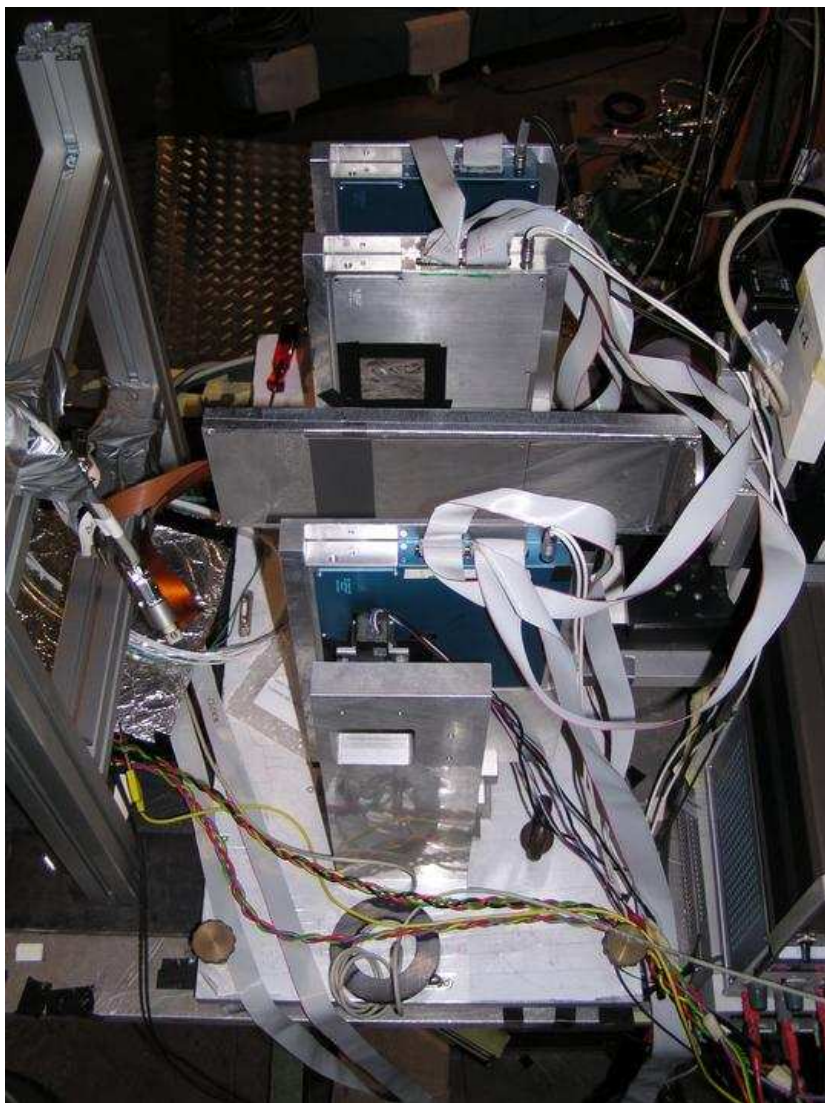
- Testbeams
 - DESY: MIP
 - Erlangen: Low Energy protons
- Laser Test Stand
- Detailed noise optimisation
- RF tests → Z. Ye's talk (T401.5)
- Parameter tests → I. Hristova's talk (T301.8)

Testbeam at DESY

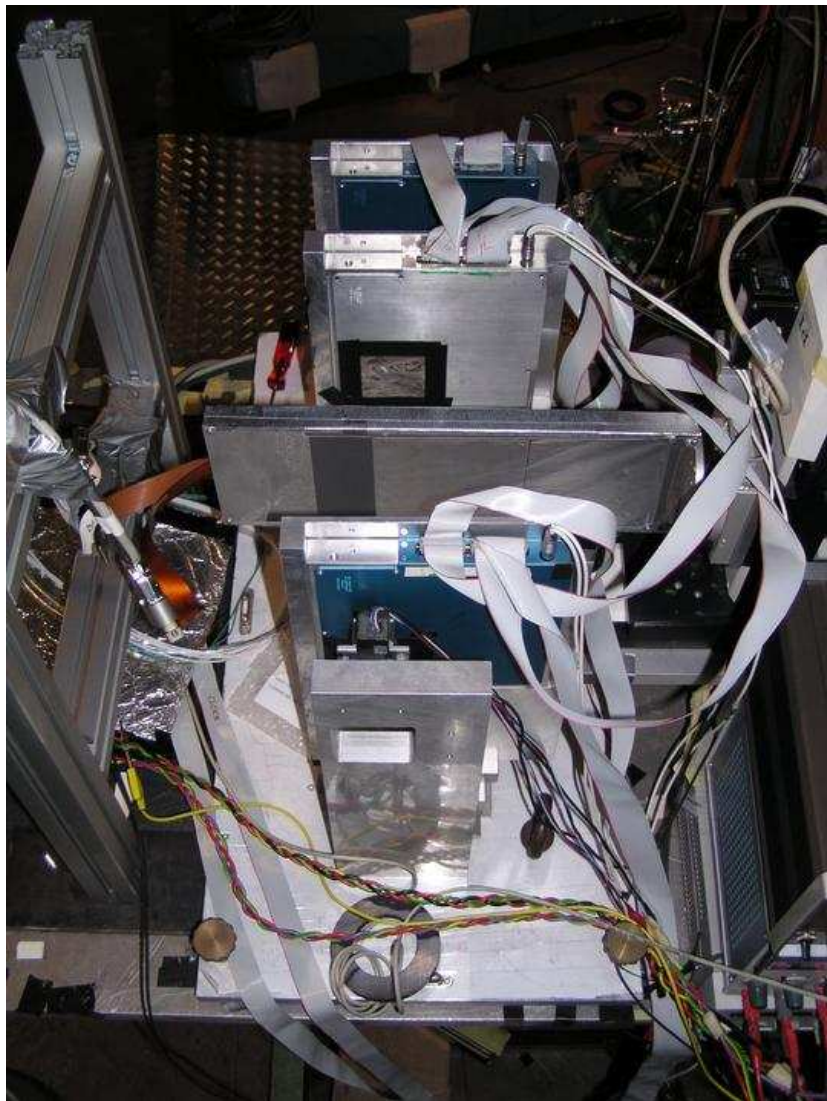
- Electrons from pre-accelerator DESYII (1-6 GeV)
- Use Zeus Telescope
 - 6 Reference detectors
 - $\frac{S}{N} > 60$
 - pitch 25 (50) μm



Testbeam at DESY



Testbeam at DESY



'Pre' Prototype:

→ $\frac{S}{N} = 7.5$

→ $\epsilon = 99.73 \pm 0.04\%$

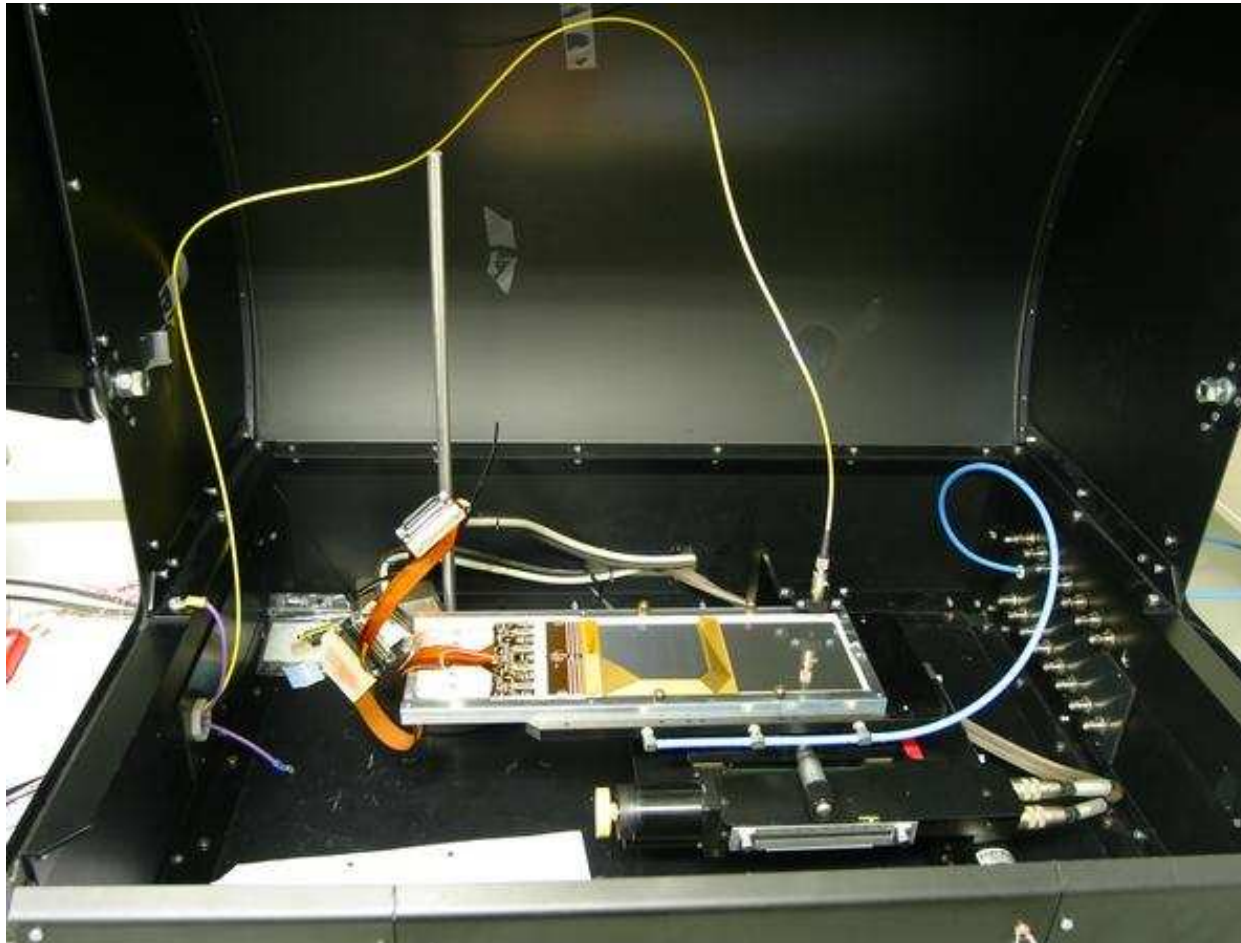
'Final' Prototype:

→ $\frac{S}{N} \sim 6.2$

Erlangen Testbeam

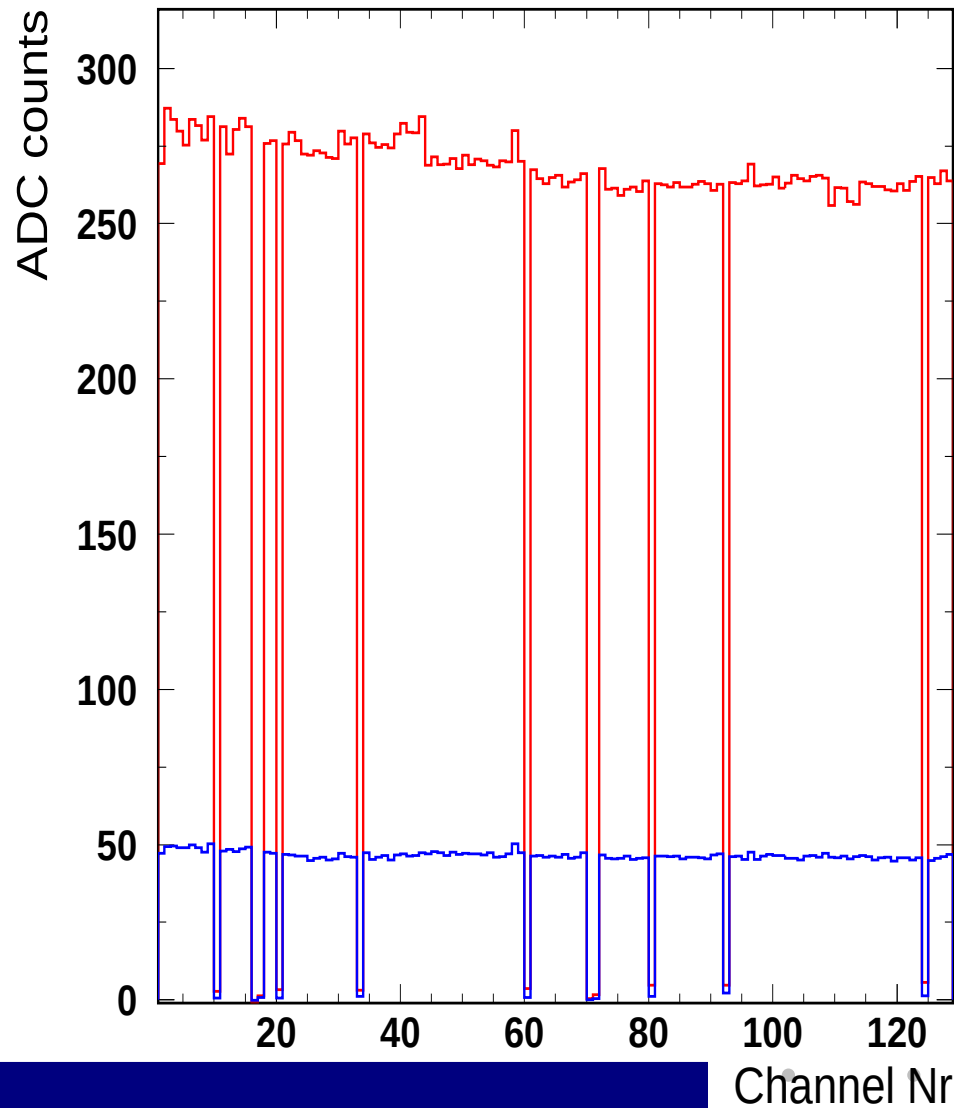
- Double Van De Graaff Accelerator
- Protons up to 11 MeV
- First tests being analysed

Laser Test



- ➡ Black Box
- ➡ Red Laser
- ➡ X-Y Table
- ➡ Spot $\sim 20\mu m$

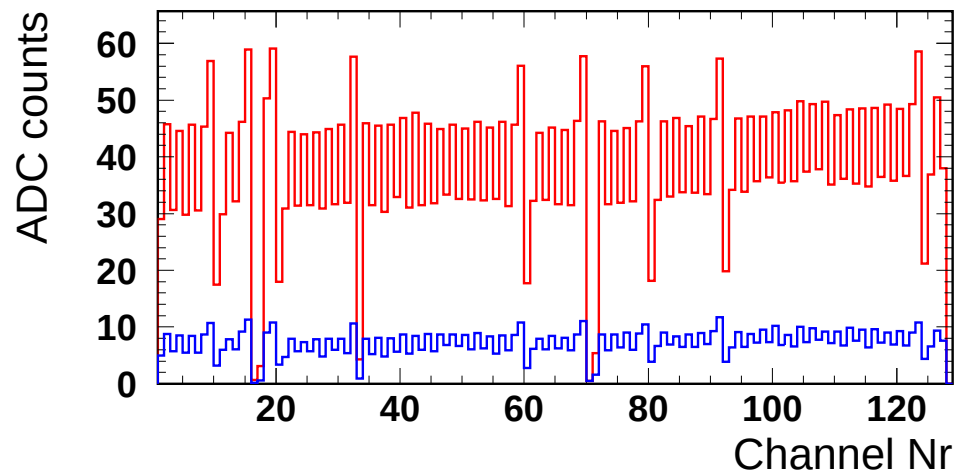
Laser Test



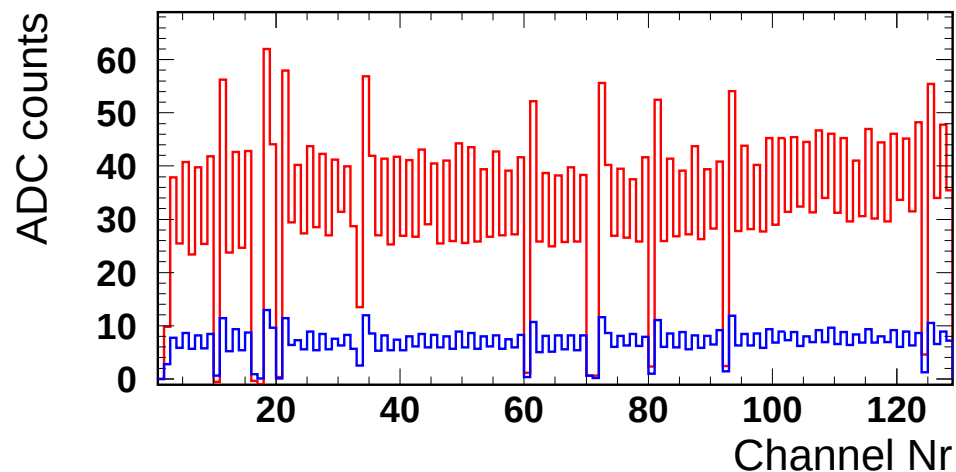
- Uniformity
- Linearity
- Pipe Spread

Laser Test

Asymmetric Crosstalk $\sim 5.1\%$



Similar as reported
by other groups



Summary

- Development of a Silicon Recoil Detector for HERMES
- Mechanical construction fixed and working
- First SRD module being tested and optimised
- Test installation in 2004